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U.S. Patent Application Serial No. 09/811,106

ATMI-513

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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APR 21 2004

In re United States Patent Application of:

Applicants: Ravi K. Laxman, et al.

Group Art Unit: 1621

Serial No.: 09/811,106

Examiner: Samuel A. Barts

Date Filed: March 17, 2001

Confirmation Number: 9357

**Title: Low Dielectric Constant Thin Films and
Chemical Vapor Deposition Method of Making
Same**

Customer No.: 25559

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Maggie Chappuis

April 21, 2004
Date of Transmission

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**AMENDMENT RESPONDING TO OCTOBER 21, 2003 OFFICE ACTION IN
U.S. PATENT APPLICATION NO. 09/811,106 AND PETITION FOR THREE
MONTH EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

U.S. Patent Application Serial No. 09/811,106

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In response to the Office Action dated October 21, 2003, applicant respectfully requests entry of the following Amendments and consideration of the subsequent remarks.